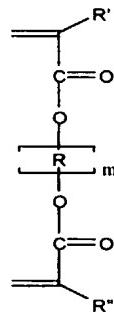


## CROSS-LINKING MONOMERS FOR PHOTORESIST, AND PROCESS FOR PREPARING PHOTORESIST POLYMERS USING THE SAME

### ABSTRACT OF THE DISCLOSURE

The present invention discloses a cross-linking monomer represented by the  
 5 following Chemical Formula 1, a process for preparing a photoresist polymer using the same,  
 and said photoresist polymer:

**<Chemical Formula 1>**



wherein, R' and R'' individually represent hydrogen or methyl; m represents a number of 1 to  
 10; and R is selected from the group consisting of straight or branched C<sub>1-10</sub> alkyl, straight or  
 branched C<sub>1-10</sub> ester, straight or branched C<sub>1-10</sub> ketone, straight or branched C<sub>1-10</sub> carboxylic  
 acid, straight or branched C<sub>1-10</sub> acetal, straight or branched C<sub>1-10</sub> alkyl including at least one  
 hydroxyl group, straight or branched C<sub>1-10</sub> ester including at least one hydroxyl group, straight  
 or branched C<sub>1-10</sub> ketone including at least one hydroxyl group, straight or branched C<sub>1-10</sub>  
 15 carboxylic acid including at least one hydroxyl group, and straight or branched C<sub>1-10</sub> acetal  
 including at least one hydroxyl group.